

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF

LEE et al.

Appln. No.: 09/751,453

Filed: January 2, 2001

Title: METHOD FOR FABRICATING CAPACITORS FOR SEMICONDUCTOR DEVICES

Confirmation No.: 7152

Group Art Unit: 2814

Examiner: Rao, Shrinivas H.

August 5, 2003

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SUPPLEMENTAL AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 20, 2002, and further to our Request for Continued Examination filed January 21, 2003 requesting entry of an Amendment filed November 20, 2002, please enter the following amendments and remarks:

FAX RECEIVED

AUG - 5 2003

TECHNOLOGY CENTER 2800